

# **Microcontamination Sensor For VLSI Semiconductor Manufacturing By Pajo Vujkovic-Cvijin**

**By Pajo Vujkovic-Cvijin**

## **Surface Inspection Research and Development - NASA -**

Surface Inspection - Research and Development at microcontamination detection from both a The decreasing defect densities required for the next VLSI

## **Proceedings of SPIE Volume 3213 - SPIE - the -**

Proceedings of SPIE Volume 3213 and sizing results from different sensors in semiconductor process in metal defects for VLSI

## **ASYST TECHNOLOGIES INC - Annual Report (Regulation -**

and factory automation solutions used primarily in cleanrooms for semiconductor manufacturing. VLSI Technology microcontamination control and product

## **Handbook of Thin Film Deposition Processes and -**

and David M. Sanders HANDBOOK OF VLSI Silicon oxidation H2 mass flow controller with a second sensor that measures the concentration of chemical

## **Positioning Arizona and its research universities: -**

Positioning Arizona and its research universities: science and technology core competencies assessment

## **Patent US5024766 - Point of use deionized water -**

A pump low pressure cutout sensor 164 is Cleaning in VLSI Production , Microcontamination, on Silicon Wafer Surfaces , Microcontamination, pp

## **CiteSeerX REVIEW ARTICLE How will physics be -**

ultra-clean processing and microcontamination. {REVIEW ARTICLE How will physics be involved in} The importance of European silicon VLSI - Dunn

## **SPIE | Volume -**

IN THIS VOLUME. Contamination and Comparison of submicron particle counting and sizing results from different sensors in semiconductor Very large scale

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Award Title Agency Phase Award amount Start Date End Date;  
Microcontamination Sensor for VLSI Semiconductor Manufacturing LOS Gatos  
Research Principal Investigator

**Patent US6906799 - Signal processing method for -**

This invention relates to the field of semiconductor wafer processing, sensors can provide continuous monitoring of particulate Microcontamination, 8

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**Prof. Ohmi's Paper -**

Characterization of Epitaxial Silicon Films Formed by a Low Kinetic  
Microcontamination, Vol. 7, No 1989 International Symposium on VLSI  
Technology

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**Patent US6631019 - Reconfigurable multichannel -**

A high performance reconfigurable DWDM transmitter incorporates discrete optical components placed in v grooves etched in a substrate. Direct wavelength monitoring

**Patent US7081657 - MEMS and method of -**

wherein the first layer and the second layer comprise a material selected from the group consisting of semiconductor, based sensors. VLSI Device Layer

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**Ultra clean processing - ScienceDirect.com -**

It is demonstrated that ultra clean technology is a in future semiconductor 166 T.  
Ohmi / Ultra clean factor, Microcontamination 6(10

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The sensor uses laser light scattering in situ particle monitoring in production  
medium current implantation, IEEE Transactions on Semiconductor

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Microcontamination Control Semiconductor Consumables Semiconductor Capital  
Equipment,

## **Bijan Moslehi | Sigma Xi | ZoomInfo.com -**

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and semiconductor manufacturing industry as well as microcontamination,

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semiconductor process in metal defects for VLSI

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ULSI Technology Chapter01 Sensors are installed Closed System Essential for  
HighQuality Processing within Advanced Semiconductor Lines,"  
Microcontamination, 8

## **Characterization and Metrology for ULSI -**

The proceedings of the 1998 International Conference on Characterization and  
Metrology for ULSI semiconductor techniques that are A Microcontamination  
Model

## **Particle contamination in implanters - -**

require that lower levels of particle contamination must sensor produces a laser  
beam Semi- nar, Interface '84. Microcontamination

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Electronics & Computer Engineering Technology semiconductor devices, sensor technology, emission control, sensors, microcontamination;

## **IEEE Xplore: Semiconductor Manufacturing, IEEE -**

Semiconductor Manufacturing, IEEE Transactions on the microcontamination analysis on wafers individually to sensors to achieve a multiloop

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